# Homework 5 - Aidan Sharpe

## Problem 1

If the gate oxide thickness in a  $SiO_2$ -based structure is 2[nm], what would be the thickness of an  $HfO_2$ -based dielectric providing the same capacitance?

$$k_{\rm SiO2} = 3.9$$

$$k_{\rm HfO2} = 20$$

$$2[\text{nm}]\frac{2.0}{3.9} = \boxed{10.26[\text{nm}]}$$

## Problem 2

Using the SUBM rules, clculate the minimum uncontacted and contacted transistor pitch.

### Uncontacted

$$\lambda + 3\lambda + \lambda = \boxed{5\lambda}$$

#### Contacted

$$\lambda + 2\lambda + 2\lambda + 2\lambda + \lambda = \boxed{5\lambda}$$